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PATENT

5589-11400/P1618

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re Application of:
Dardzinski**

Serial No. 10/723,585

Filed: November 26, 2003

**For: METHOD AND APPARATUS FOR
INSPECTING A SEMICONDUCTOR
WAFER**

Group Art Unit: 2877
Examiner: Nguyen, Sang H.

Atty. Dkt. No. 5589-11400

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: MS: Non-Fee Amendment Commissioner for Patents, P.O. Box 1450, Alexandria, VA, 22313-1450 on the date indicated below:

3-1-06

Data

Bamela Denton

Pamela Gerik

AMENDMENT; RESPONSE TO OFFICE ACTION MAILED DECEMBER 1, 2005

MS: Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

This paper is submitted in response to the Office Action mailed December 1, 2005 to further highlight reasons why the application is in condition for allowance.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.